IN THE CLAIMS

Please cancel claims 3 and 6-10 without prejudice, and amend the claims as follows:

- (currently amended) A method for producing a quartz glass blank, said method comprising: a method step in which SiO₂ particles are produced by a row of deposition burners and deposited on a cylinder outer surface of a carrier rotating about a longitudinal axis thereof to form a cylindrical porous SiO₂ soot body, a temperature adjustment body altering a surface temperature of the soot body as it is being formed, wherein the temperature adjustment body comprises one or more reflector elements a planar element extending along a substantial part of the SiO₂ soot body, the reflector element or elements acting which either acts as a homogeneous heat sink and has a temperature-shielding effect on the soot body surface or, acts as a homogeneous reflector with a reflectance for IR radiation between 80% and 100%, and having has a temperature-raising effect due to heat radiation, and having an efficiency, defined as a solid angle covering the forming SiO₂ soot body, of at least 60%.
- (currently amended) The method according to claim 1, wherein said <u>reflector element</u>
 or elements planar element is formed by an inner wall of a housing surrounding the
 SiO₂ soot body.
- 3. (canceled)
- 4. (currently amended) The method according to claim 3, wherein heat of the deposition burners is reflected towards the soot body by means of the <u>reflector element or elements planar element</u>.
- 5. (currently amended) The method according to claim 3, wherein heat of the forming SiO₂ soot body is reflected by means of the <u>reflector element or elements</u> planar element towards the soot body surface.

| 6. | (canceled) |
|-----|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
| 7. | (canceled) |
| 8. | (canceled) |
| 9. | (canceled) |
| 10. | (canceled) |
| 11. | (currently amended) The method according to claim 3, wherein the <u>reflector element or elements</u> planar element is moved along the soot body. |
| 12. | (currently amended) The method according to claim 3, wherein the distance between the <u>reflector element or elements</u> planar element and the surface of the forming SiO ₂ soot body is kept constant. |
| 13. | (currently amended) The method according to claim 1, wherein the <u>reflector element or elements</u> planar element extends over the whole usable length of the soot body. |
| 14. | (canceled) |
| 15. | (canceled) |
| 16. | (canceled) |
| 17. | (canceled) |
| 18. | (canceled) |

- 19. (canceled)
- 20. (canceled)
- 21. (canceled)
- 22. (canceled)
- 23. (canceled)
- 24. (canceled)
- 25. (canceled)
- 26. (canceled)